



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Gurtej S. Sandhu and Sujit Sharan

§
§ Group Art Unit: 1763

Serial No.: 09/439,314

§
§ Examiner: Thi Dang

Filed: November 12, 1999

§
§ Atty. Docket: 95-0392.02

For: DEVICE FOR IN-SITU CLEANING OF
INDUCTIVELY-COUPLED PLASMA CHAMBERS

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§

FIRST AMENDMENT AND RESPONSE TO THE
OFFICE ACTION DATED AUGUST 30, 2000

Certificate of Mailing (37 C.F.R. § 1.8)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid, in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on the date below:

2/28/01



Charles Brown
Signature

Date

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Applicants herein respond to the Office Action of August 30, 2000. Please amend the above-captioned application as follows.

IN THE SPECIFICATION

Please change the title from "DEVICE FOR IN-SITU CLEANING OF INDUCTIVELY-COUPLED PLASMA CHAMBERS" to --DEVICE FOR IN-SITU CLEANING OF AN INDUCTIVELY-COUPLED PLASMA CHAMBER--.

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